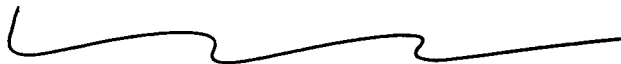
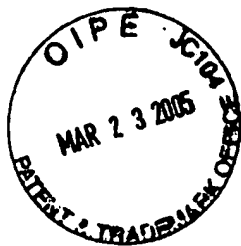


JPW

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b>					<b>Docket No.</b> SEC.1034CIP	
Applicant(s): Kyeong-mo KOO et al.						
Application No. 10/686,768	Filing Date October 17, 2003	Examiner Thao P. LE	Customer No. 20987	Group Art Unit 2818	Confirmation No. 7742	
Invention: METHOD OF FORMING COBALT SILICIDE FILM AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING COBALT SILICIDE FILM						
<u>COMMISSIONER FOR PATENTS:</u>						
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.						
<b>CLAIMS AS AMENDED</b>						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	49 -	50 =	0	x \$50.00	\$0.00	
INDEP. CLAIMS	6 -	6 =	0	x \$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00	
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>					<b>\$0.00</b>	
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038. <b>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</b>						
 _____ Signature			Dated: March 23, 2005			
LINUS Y. PARK Reg. No. 45,261 Volentine Francos & Whitt, P.L.L.C. One Freedom Square 11951 Freedom Drive, Suite 1260 Reston, VA 20191 Tel. No. 571-283-0720			<div style="border: 1px solid black; padding: 5px;"><p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on</p><p>_____ (Date)</p><p>_____ Signature of Person Mailing Correspondence</p><p>_____ Typed or Printed Name of Person Mailing Correspondence</p></div>			
CC:						



Application No. 10/686,768  
SEC.1034CIP  
Amendment dated: March 23, 2005

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re PATENT APPLICATION of :  
Kyeong-mo Koo : Group Art Unit: 2818  
Application No.: 10/686,768 : Examiner: Thao P. Le  
Filed: October 17, 2003 :

METHOD OF FORMING COBALT SILICIDE FILM AND METHOD OF  
MANUFACTURING SEMICONDUCTOR DEVICE HAVING COBALT  
SILICIDE FILM

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**AMENDMENT AND REQUEST FOR  
RECONSIDERATION**

U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office Action dated March 8, 2005, the Applicants submit the following claims amendment, and remarks and arguments regarding the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 17 of this paper.